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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/071,425
Filing Date February 8, 2002
Inventor Terry L. Gilton et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Thanhha S. Pham
Attorney Docket No. MI22-1828
Customer No. 021567
Title: Semiconductor Processing Method Using Photoresist and an Antireflective
Coating

INFORMATION DISCLOSURE STATEMENT

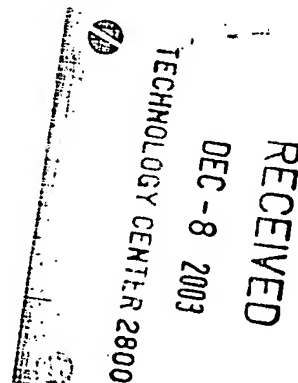
References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 11-21-03By: 

Mark S. Matkin
Reg. No. 32,268



Form PTO-1449

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LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)

ATTY. DOCKET NO.
MI22-1828

SERIAL NO.
10/071,425

APPLICANT: Terry L. Gilton et al.

FILING DATE
February 8, 2002

GROUP
2813

U.S. PATENT DOCUMENTS

*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	4,127,414	11/28/78	Yoshikawa et al.			
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AJ							
AK							
AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AM		
AN		
AO		

EXAMINER

DATE CONSIDERED

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